

<b>AMENDMENT TRANSMITTAL LETTER</b>				Docket No. 3430-0131P	
Application No. 09/648,111-Conf. #5562		Filing Date August 25, 2000		Examiner A. R. Wilson	
				Art Unit 2815	

Applicant(s): Kwang-Jo HWANG

Invention: METHOD OF PATTERNING A METAL LAYER IN A SEMICONDUCTOR DEVICE

**MS Amendment**  
 Commissioner for Patents  
 P.O. Box 1450  
 Alexandria, VA 22313-1450

Transmitted herewith is an amendment in the above-identified application.  
 The fee has been calculated and is transmitted as shown below.

CLAIMS AS AMENDED						
	Claims Remaining After Amendment	Highest Number Previously Paid		Number Extra Claims Present	Rate	
<b>Total Claims</b>	25	- 30	=	0	x 52.00	0.00
<b>Independent Claims</b>	4	- 4	=	0	x 220.00	0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>						
Other fee (please specify):						
<b>TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:</b>						0.00

☒ Large Entity ☐ Small Entity

☒ No additional fee is required for this amendment.

☐ Please charge Deposit Account No. \_\_\_\_\_ in the amount of \$ \_\_\_\_\_.  
 A duplicate copy of this sheet is enclosed.

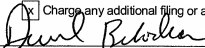
☐ A check in the amount of \$ \_\_\_\_\_ is enclosed.

☐ Payment by credit card. Form PTO-2038 is attached.

☒ The Director is hereby authorized to charge and credit Deposit Account No. 02-2448  
 as described below. A duplicate copy of this sheet is enclosed.

☒ Credit any overpayment.

☒ Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.

  
 \_\_\_\_\_  
 Esther H. Chong  
 Attorney Reg. No.: 40,953

Dated: July 1, 2009

BIRCH, STEWART, KOLASCH & BIRCH, LLP  
 8110 Gatehouse Road  
 Suite 100 East  
 P.O. Box 747  
 Falls Church, Virginia 22040-0747  
 (703) 205-8000

**DAVID A. BILODEAU**  
**USPTO #42,325**